

<b>Notice of References Cited</b>	Application/Control No. 09/470,343	Applicant(s)/Patent Under Reexamination MARTINEZ-TOVAR ET AL.	
	Examiner Troy Chambers	Art Unit 3641	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,798,475	08-1998	Reynes et al.	102/202.5
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Characteristics of semiconductor bridge (SCB) plasma generated in a micro-electro-mechanical system (MEMS), Jong-Uk Kim, October 2002.
	V	
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a) )  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.